



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hideki KOMATSUDA

Application No.: 09/697,639

Filed: October 27, 2000

For: EXPOSURE APPARATUS AND METHOD OF FABRICATING A MICRO DEVICE
USING THE EXPOSURE APPARATUS

Group Art Unit: 2851

Examiner: R. Fuller

Docket No.: 105193.01

#12
1-22-03
qfr

INFORMATION DISCLOSURE STATEMENT

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed with a Request for Continued Examination. No certification or fee is required.
- ☒ 2. English-language Abstracts of the non-English language references are attached hereto.

Respectfully submitted,

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MAC/ccs

Date: December 16, 2002

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